Electronic Acknowledgement Receipt				
EFS ID:	1425711			
Application Number:	10710244			
International Application Number:				
Confirmation Number:	4243			
Title of Invention:	STRUCTURES AND METHODS FOR MANUFACTURING P-TYPE MOSFET WITHGRADED EMBEDDED SILICON-GERMANIUM SOURCE-DRAIN AND/OR EXTENSION			
First Named Inventor/Applicant Name:	Huilong Zhu			
Customer Number:	32074			
Filer:	Joseph P. Abate/Robert Faber			
Filer Authorized By:	Joseph P. Abate			
Attorney Docket Number:	FIS920040116US1			
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Application Type:	Utility			

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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	FIS920040116US1_Amend ment_01-09-2007.pdf	226618	no	7
Warnings:					

Information:	
Total Files Size (in bytes):	226618

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.